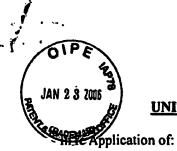
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## **UNITED STATES PATENT AND TRADEMARK OFFICE**

Yoshihide SENZAKI

Serial No.: 10/766,618

Filed: January 27, 2004

For: MULTILAYER HIGH K

DIELECTRIC FILMS AND

METHOD OF MAKING THE

SAME

Examiner: NGUYEN, HA T

Group Art Unit: 2812

Confirmation No.: 3758

San Francisco, CA 94111

Date: January 20, 2006

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JW2.06

## AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed on November 25, 2005, please consider the following proposed amendments to the above-identified application and the remarks herein.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

4824-6094-5152\2